



## Supplementary materials

# Flexible Piezoresistive Pressure Sensor Based on Electrospun Rough Polyurethane Nanofibers Film for Human Motion Monitoring

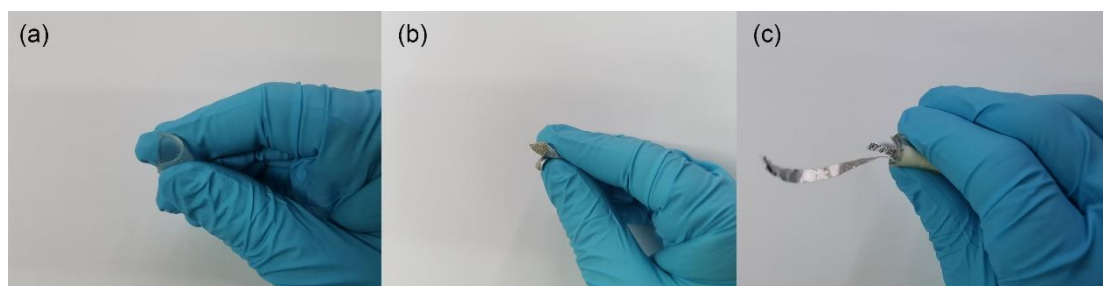
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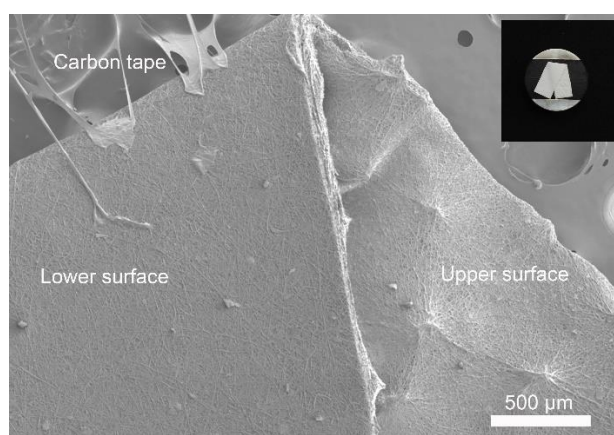
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**Figure S1.** The photograph of the electrospinning unit.



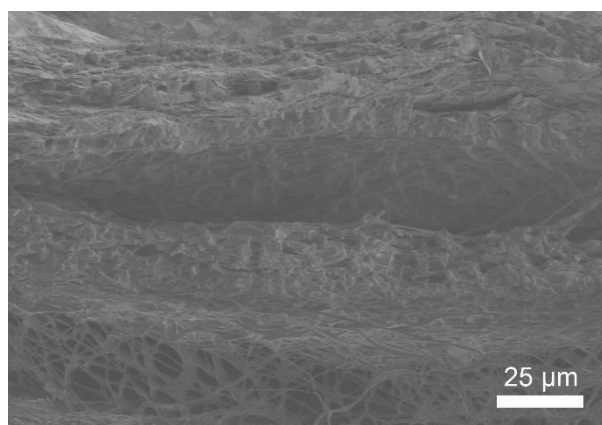
**Figure S2.** Photographs of (a) PDMS, (b) PU/Ag film, and (c) the fabricated piezoresistive pressure sensor at a bending state.



**Figure S3.** An SEM image of the electrospun PU nanofibers film. The inset is a photograph of the film fixed on the sample holder with carbon tape.



**Figure S4.** A photograph of the electrospun PU nanofibers film.



**Figure S5.** A high magnification cross-section SEM image of PU/Ag film.

**Table S1.** A comparison of other types of sensors reported recently with the proposed sensor.

Active material	Sensing mechanism	Maximum sensitivity	Stability	Ref.
PI-MWCNTs/microstructured PDMS	Capacitance	1.3 kPa <sup>-1</sup>	> 4000 cycles	[34]
PDMS/PVDF BaTiO <sub>3</sub> filler	Capacitance	4.9 kPa <sup>-1</sup>	5000 cycles	[35]
PDMS	Capacitance	44.5 kPa <sup>-1</sup>	5000 cycles	[36]
ITO coated PET/porous PDMS	Capacitance	0.095 kPa <sup>-1</sup>	N/A	[37]
porous PDMS/CNT film	Capacitance	2.51 kPa <sup>-1</sup>	5000 cycles	[38]
BCZT/PDMS	Piezoelectric	~0.55 V kPa <sup>-1</sup>	2×10 <sup>6</sup> cycles	[39]
Hierarchical ZnO NRs/PVDF	Piezoelectric	11.07 mV kPa <sup>-1</sup>	3600 cycles	[40]
ZnO@C/PVDF	Piezoelectric	0.98 V kPa <sup>-1</sup>	4000 cycles	[41]
MXene/PVDF hybrid film	Piezoelectric	0.0480 V N <sup>-1</sup>	N/A	[42]
PDA@BTO/PVDF	Piezoelectric	0.38 V N <sup>-1</sup>	6834 cycles	[43]
Microstructured PU/Ag film	Piezoresistive	10.53 kPa <sup>-1</sup>	10000 cycles	This work

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